

DEFORMATION FIELD MAPPING OF THE X-RAY SILICON FRESNEL ZONE PLATE

<u>A. Barannikov¹, D. Zverev¹, M. Sorokovikov¹, V. Yunkin², I. Snigireva³, and A. Snigirev¹</u>

¹Immanuel Kant Baltic Federal University, 14 A. Nevskogo, Kaliningrad 236041, Russia ²Institute of Microelectronics Technology RAS, 6 Institutskiy Prospekt, Chernogolovka 142432, Russia ³European Synchrotron Radiation Facility (ESRF), 71 avenue des Martyrs, Grenoble 38043, France

Email: abarannikov95@gmail.com

ABSTRACT

The X-ray topography technique is very sensitive to the crystal lattice misorientations in the monocrystals. It was implemented in studying of the deformations of the X-ray silicon Fresnel Zone Plate (FZP). The research was performed at the ID06 ESRF beamline using the 12.38 keV radiation energy. During the experiment, the contour map of the FZP deformation field was obtained. This map was used in the reconstruction of the surface curvature profile at three points: at the FZP center, 60 μ m, and 120 μ m below the FZP center. As result, the FZP with 242 zones has a concave profile in its center and a convex profile near the outermost zones. This technique can be used not only for the characterization of the conventional binary FZP but also for the Multilayer Laue Lenses and FZP with multilevel, and kinoform profiles.

SAMPLE DESCRIPTION







 $\pm \Delta \theta$ SCAN



SUM of the images

DEFORMATION FIELD MAPPING





Stereo images with isolines recorded during the FZP rotation at the different angles $\pm \Delta \theta$.



(a) Contour map obtained by the summation of the stereo images. (b) The horizontal deformation profiles of the FZP reconstructed at the different positions. The inflection points of the central profile are marked by A and B.

The research was conducted with the financial support of the Ministry of Science and Higher Education of the Russian Federation, Contract Nº 075-15-2021-966 from 30.09.2021.